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|--|---|--|-------------|
| ٠.   | Application No.   | Applicant(s)   |             |
| Notice of Allowability   | 10/770,278<br>Examiner  | MOUMEN, NAIM Art Unit  | <del></del> |
|  | Yennhu B. Huynh   | 2813   |             |
| The MAILING DATE of this communication app<br>All claims being allowable, PROSECUTION ON THE MERITS IS<br>herewith (or previously mailed), a Notice of Allowance (PTOL-85<br>NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F<br>of the Office or upon petition by the applicant. See 37 CFR 1.31   | pears on the cover sheet with<br>S (OR REMAINS) CLOSED in<br>S) or other appropriate communication is su  | this application. If not included<br>ication will be mailed in due course  |             |
| 1. This communication is responsive to <u>2/2/04</u> .   |   |  |             |
| 2. The allowed claim(s) is/are <u>14-20</u> .  |   |  |             |
| 3. $\boxtimes$ The drawings filed on <u>02 February 2004</u> are accepted by   | the Examiner.   |  |             |
| 4. Acknowledgment is made of a claim for foreign priority to a) All b) Some* c) None of the:  1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)).  * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE"   | re been received. re been received in Application ocuments have been received " of this communication to file   | No in this national stage application fro  |             |
| noted below. Failure to timely comply will result in ABANDONI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  5. A SUBSTITUTE OATH OR DECLARATION must be subr INFORMAL PATENT APPLICATION (PTO-152) which give  | nitted. Note the attached EXA   |  | E OF        |
| <ol> <li>CORRECTED DRAWINGS (as "replacement sheets") mu         <ul> <li>(a) including changes required by the Notice of Draftspel</li> <li>1) hereto or 2) to Paper No./Mail Date</li> <li>(b) including changes required by the attached Examiner Paper No./Mail Date</li> <li>Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in</li> </ul> </li> <li>7. DEPOSIT OF and/or INFORMATION about the department of the dep</li></ol> | rson's Patent Drawing Review   r's Amendment / Comment or i  1.84(c)) should be written on the the header according to 37 CFF osit of BIOLOGICAL MATE | n the Office action of e drawings in the front (not the back) 1.121(d). RIAL must be submitted. Note the   |             |
| <ul> <li>Attachment(s)</li> <li>1. ☑ Notice of References Cited (PTO-892)</li> <li>2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date 2/2/04</li> <li>4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ul>  | 6. ☐ Interview Su<br>Paper No./M<br>/08), 7. ☒ Examiner's A   | ormal Patent Application (PTO-152) mmary (PTO-413), fail Date mendment/Comment  Statement of Reasons for Allowance CARL WHITEHEAD, R. SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800 |             |

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#### **DETAILED ACTION**

This Office Action is in response to the Preliminary Amendment filed on 02/02/04.

Claims 1-13 are cancelled by the Preliminary Amendment filed on 02/02/04.

#### Information Disclosure Statement

The information disclosure statement filed on 2/2/04 is being considered by the examiner.

## Oath/Declaration

Oath/Declaration filed on 2/2/04 is accepted.

## **EXAMINER'S AMENDMENT**

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Leslie Szivos on 03/27/05.

The claim has been changed as follows:

In claim 15 lines 2, the recited limitation --25/min-- changed to -- 25Angstroms/min--.

## Allowable Subject Matter

Claims 14-20 are allowable over the prior art of record.

The following is an examiner's statement of reasons for allowance: Prior art of record does not disclose a method of a collar formation using selective SiGe/Si etch.

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which include the steps of etching a structure containing exposed surface of amorphous Si and SiGe with an aqueous solution of HF to remove oxide from the exposed surface; and etching the exposed amorphous Si surfaces with an aqueous NH<sub>4</sub>OH to selectively remove the amorphous Si at a faster than the SiGe.

Burns et al. (6,258,679B1) disclose etching a structure containing an amorphous silicon and SiGe with a highly selective HF for remove oxide layer on the exposed surface, but not with an aqueous HF (col.4 lines 45-53).

Mercaldi et al. (6,316,370) disclose etching a structure containing an amorphous silicon or SiGe with a highly selective HF acid (or aqueous HF) but not for remove oxide layer on the exposed surface (col.3 lines 34-44 and col. 4 lines 28-35 and 55-60).

Aspnes et al. (US. 4,380,490) disclose etching a structure containing an Si and Ge substrate, but do not disclose amorphous silicon and SiGe, wherein the etching use with highly selective HF to remove oxide. Aspnes also disclose etching the substrate with NH<sub>4</sub>OH (col.3 & 4), but do not disclose wherein the aqueous NH4OH remove the silicon faster than the germanium.

Sakaguchi et al. (US 5,277,748) disclose etching a substrate containing Si but not amorphous silicon, and SiGe with HF etching, wherein the etching rate on Si is higher than SiGe (col. 3 & 4 lines 50-9), but do not disclose the etching is used by NH<sub>4</sub>OH.

Therefore the above reference is improperly combined with each other.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably

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# Conclusion

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Yennhu B. Huynh whose telephone number is 571-272-1692. The examiner can normally be reached on M-F 8.30AM-7.00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead, Jr., can be reached 571-272-1702. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

YNBH,

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